



AE / 2817

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazuhiro IKURUMI et al.

: Confirmation No. 5095

Serial No. 09/826,827

: Docket No. 2001_0409A

Filed April 6, 2001

: Group Art Unit 2817

: Examiner Dean O. Takaoka

METHOD AND APPARATUS FOR ADJUSTING
IMPEDANCE OF MATCHING CIRCUIT

AMENDMENT AFTER FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the final Office Action of October 16, 2003, please amend the above-identified U.S. Patent application as follows: